500.45763X00

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants:

T. KASUKABE et al

Application No.:

10/562,797

Filed:

December 29, 2005

For:

PROBE CARD AND SEMICONDUCTOR TESTING DEVICE

USING PROBE SHEET OR PROBE CARD AND

SEMICONDUCTOR DEVICE PRODUCING METHOD

Art Unit:

2829

Examiner:

R. ISLA RODAS

CONF. NO. 8707

UNDER 37 CFR §§ 1.97 & 1.98

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450 February 29, 2008

Sir:

In the matter of the above-identified application, applicants are submitting herewith copies of the non-U.S. patent documents listed in the attached form PTO/SB/08A listing documents from a communication from a foreign patent office in a counterpart foreign application for the Examiner's consideration.

This Information Disclosure Statement is being submitted after the mailing date of a final action but before payment of the issue fee and is accompanied by the fee of \$180.00 set forth in 37 CFR §1.17(p) and the following certification specified in 37 CFR §1.97(e):

On information and belief, I hereby certify that each item of information contained in this Information Disclosure Statement was cited in a communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this statement.

Each of the documents listed on the attached form PTO/SB/08A is in the English language.

It is respectfully requested that this Information Disclosure Statement be considered by the Examiner.

Please charge any shortage in the fees due in connection with the filing of this paper, including extension of time fees, to the deposit account of Antonelli, Terry, Stout & Kraus, LLP, Deposit Account No. 01-2135 (500.45763X00) and, please credit any excess fees to such deposit account.

Respectfully submitted, ANTONELLI, TERRY, STOUT & KRAUS, LLP

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LIST OF CITED REFERENCES

The following is the list of the references cited in an office action issued on November 30, 2007 in the corresponding Chinese Patent application :

	References
1. EP 0	999451A2
2. US P	Patent No. 6507204
3.	
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Remarks:

Partial Translation of Office Action

Mailing Date of the Office Action: November 30, 2007 Chinese Patent Application No. 200480018666.4

Cited reference(s):

October 5, 2000
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